Search Notes

Appl	lication	Control	No.
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Applicant(s)/Patent under Reexamination

09/901,595

NAKANO, SHIGERU Art Unit

Examiner

2167

Jack M. Choules

SEARCHED				
Class	Subclass	Date	Examiner	
707	10,104.1	12/15/2005	JMC	
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INTERFERENCE SEARCHED				
Subclass	Date	Examiner		
10,104	12/15/2005	ЈМС		
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	Subclass	Subclass Date		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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